

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki TOMIMATSU

Group Art Unit: 2812

Application No.:

10/770,468

Filed: February 4, 2004

Docket No.: 118459

For:

SEMICONDUCTOR DEVICES, MANUFACTURING METHODS THEREFOR, CIRCUIT

SUBSTRATES AND ELECTRONIC DEVICES

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. English language Abstracts of the non-English language references <u>1-3 & 5-9</u> are attached hereto.
- 3. A computer-generated English language translation of the following Japanese Patent Publication has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy. See References 1-3 & 6-9.

 $\boxtimes$  4. Reference 4 corresponds to reference 5.

submitted

Registration No. 27,075

Philip A. Caramanica, Jr. Registration No. 51,528

JAO:PAC/vcj

Date: August 3, 2005

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461

Form PTO-1449 (REV. 8-83)  PATENT & TRADEMARK OFFICE  INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)  APPLICATION NO. 118459  APPLICATION NO. 10/770,468  APPLICATION NO. 118459  APPLICATION NO. 118459  APPLICATION NO. 10/770,468  APPLICATION NO. 118459  APPLICATION NO. 118459  APPLICATION NO. 118459  APPLICATION NO. 10/770,468  APPLICATION NO. 118459  APPLICATION NO. 118459  APPLICATION NO. 10/770,468  APPLICATION NO. 118459  APPLICATION	SUB CLASS
(Use several sheets if necessary)  APPLICANT Hiroyuki TOMIMATSU  FILING DATE February 4, 2004  GROUP 2812  EXAMINER	
HIROURI TOMIMATSU  FILING DATE February 4, 2004  FEAMINER  GROUP 2812	
February 4, 2004 2812  EXAMINER February 4, 2004 2812	
EXAMINER	
EXAMINER	
FOREIGN PATENT DOCUMENTS	
DOCUMENT NUMBER DATE COUNTRY CLASS	SUB CLASS
1 JP 2001-060657 A w/abstr & transl 03/06/2001 JAPAN	
2 JP 08-088316 A w/abstr & transl 04/02/1996 JAPAN	
3 JP 2001-308262 A w/abstr & transl 11/02/2001 JAPAN	
4 JP 2001-514449 A 09/11/2001 JAPAN	
5 WO 99/10925 A1 03/04/1999 WIPO	
6 JP 2000-058743 A w/abstr & transl 02/25/2000 JAPAN	
7 JP 2002-222913 A w/abstr & transl 08/09/2002 JAPAN	
8 JP 08-288455 A w/abstr & transl 11/01/1996 JAPAN	
9 JP 2004-006670 A w/abstr & transl 01/08/2004 JAPAN	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)	
	-
EXAMINER DATE CONSIDERED	
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation conformance and not considered. Include copy of this form with next communication to applicant.	if not in

Date: August 3, 2005